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CONFIRMATION NO. 1266

Bib Data Sheet									
SERIAL NUMBER 10/646,757			LASS 438	GROUP AR 1765		D		ATTORNEY DOCKET NO 241785US2X	
APPLICANTS									
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Takashi Takizawa, Tokyo, JAPAN; Tatsuo Suemasu, Tokyo, JAPAN;Masahiro Katashiro, Hachioji, JAPAN; Hiroshi Miyajima, Hachioji, JAPAN; Kazuya Matsumoto, Kamiina-gun, JAPAN; Toshihiko Isokawa, Ina-shi, JAPAN;									
** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
** 11/17/2003	IGN FILING LIGENGE	GIVAIVI Z.							
Foreign Priority claimed 35 USC 119 (a-d) conditions	yes no no yes no Met aft	tar	STATE OR	SHE	ETS	TOTA	AL	INDEPENDENT	
met Verified and	Met Allowance Verified and		COUNTRY JAPAN	DRAV 5		CLAIN 12		CLAIMS 1	
ADDRESS 22850 OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 TITLE Manufacturing method of a semiconductor substrate provided with a through hole electrode									
Trial raise of the same	101400	1000.000		<u></u>					
						☐ 1.16 Fees (Filing)			

FILING FEE RECEIVED	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:	1.17 Fees (Processing Ext. of time)		
750		☐ 1.18 Fees (Issue)		
	·	Other		
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